

<b>Notice of References Cited</b>	Application/Control No. 10/529,486		Applicant(s)/Patent Under Reexamination RIETVELD ET AL.	
	Examiner Shermanda L. Williams		Art Unit 1745	Page 1 of 1

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*	C	US-6,187,468	02-2001	Shinkai et al.	429/42
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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